

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 1763

Examiner: R. Bueker

In re Application of:

MATSUNO et al.

Application No. 09/899,183

Filed: July 6, 2001

For: VAPORIZING DEVICE FOR CVD

SOURCE MATERIALS AND CVD APPARATUS EMPLOYING THE

SAME

RESPONSE TO OFFICE ACTION

U.S. Patent and Trademark Office 220 20th Street S. Customer Window, Mail Stop Amendment Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Dear Sir:

In response to the Office Action dated April 8, 2004, please enter the following amendments and consider the following remarks.